

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ricky Amos, et al.

Examiner: Matthew C. Landau

Serial No: 09/995,031

Art Unit: 2815

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For: HIGH TEMPERATURE PROCESSING COMPATIBLE METAL GATE ELECTRODE
FOR pFETs AND METHOD FOR FABRICATION

Confirmation No: 9669

Dated: February 14, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated November 14, 2007, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on February 14, 2008.

Dated: February 14, 2008



Leslie S. Szivos, Ph.D.